

METHOD OF MANUFACTURING SILICON CARBIDE FILM
Kiyoshi Satoh, et al.
Appl. No.: Unknown Atty Docket: ASMJP.133CP1

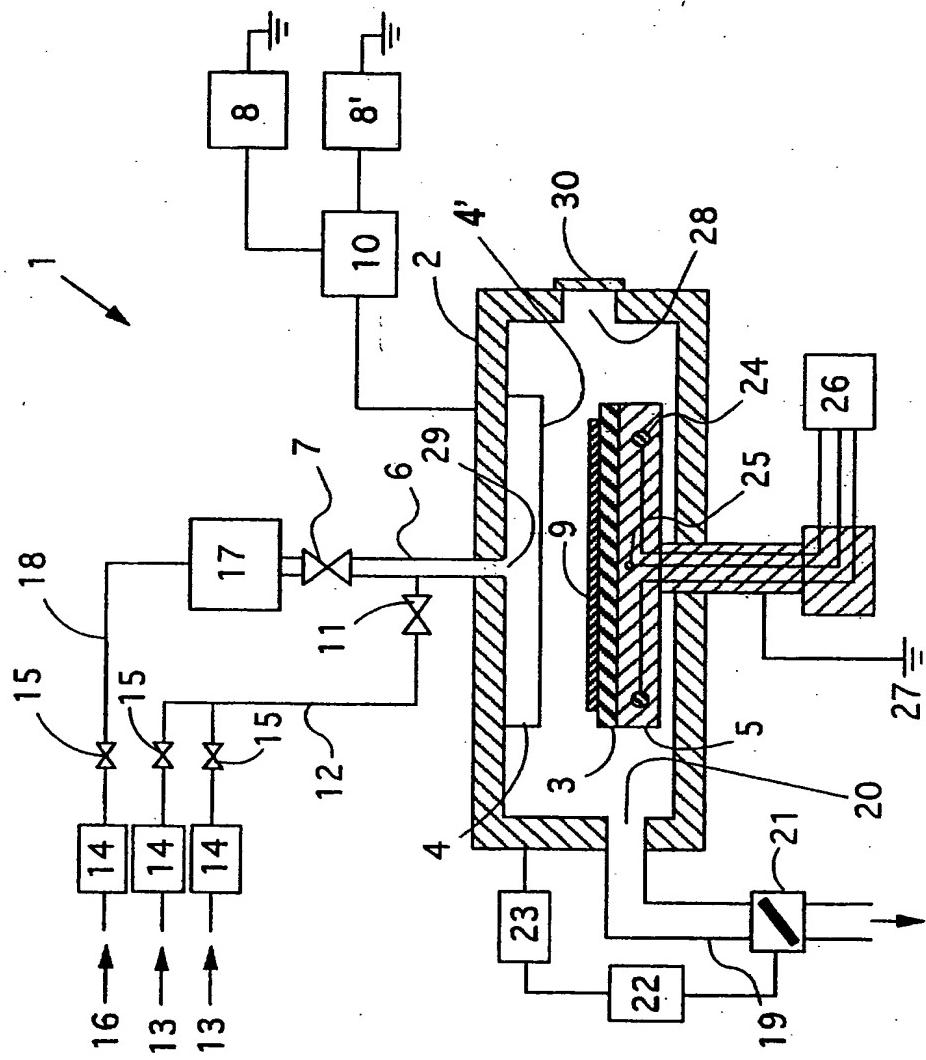


FIG. 1

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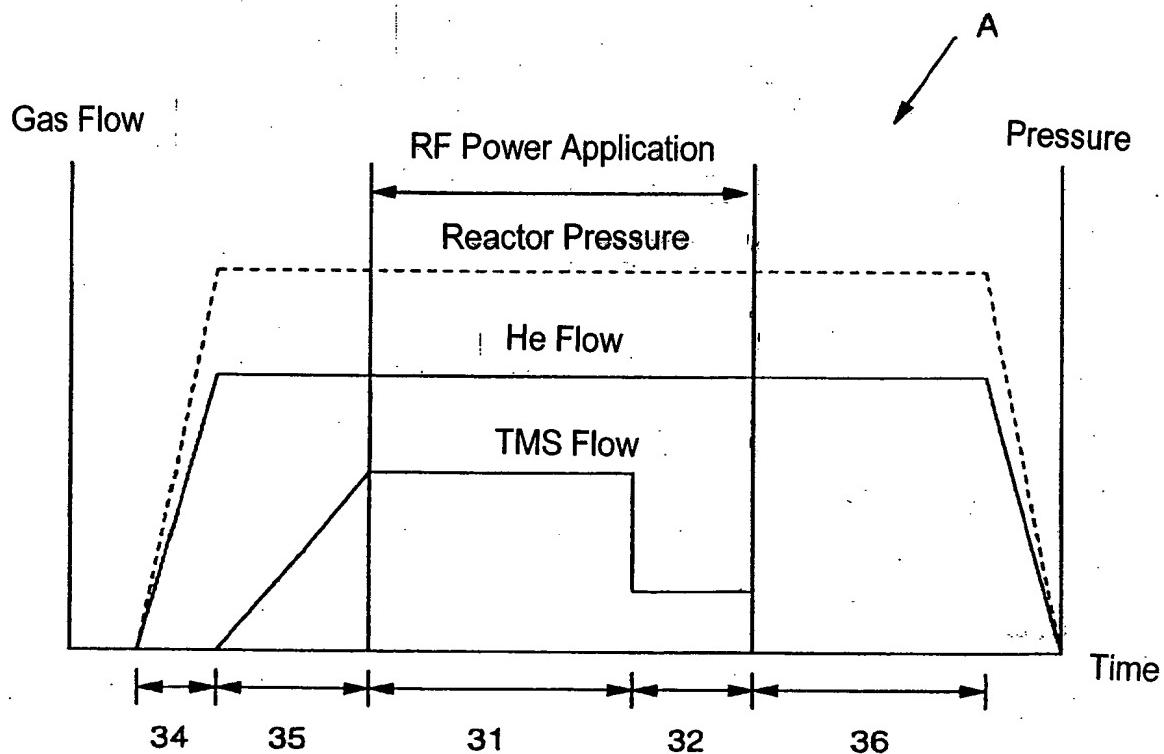


FIG. 2

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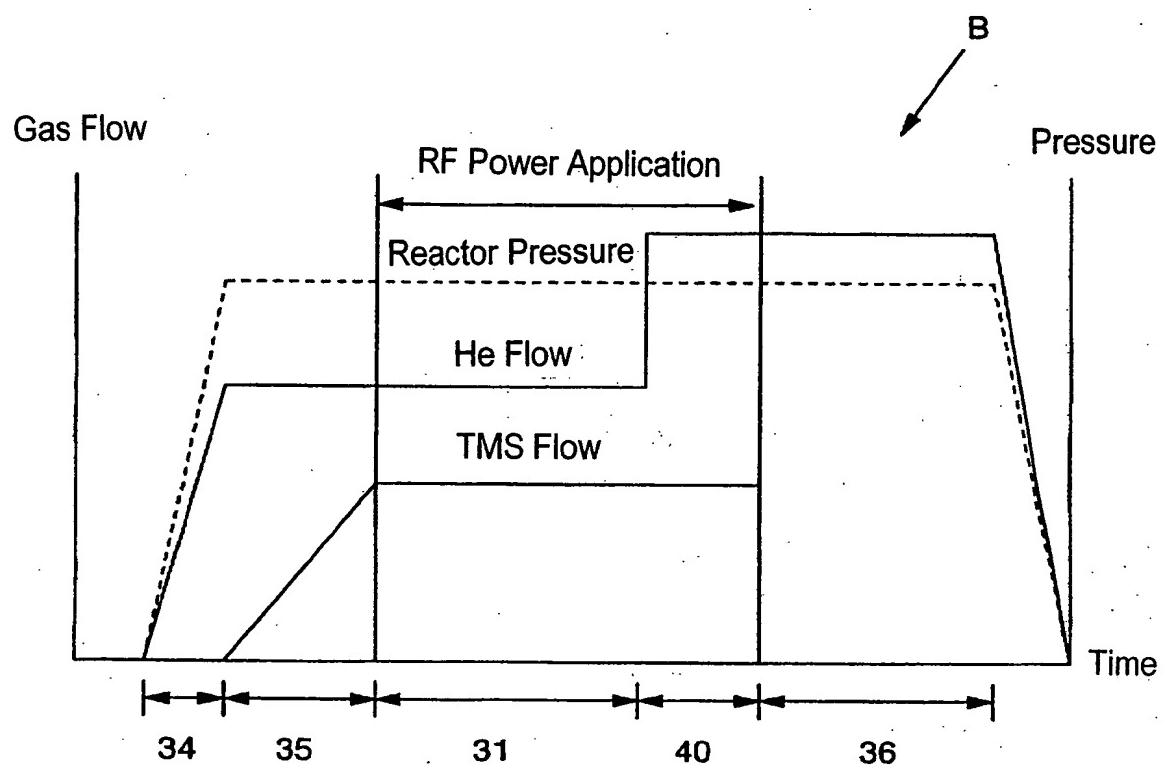


FIG. 3

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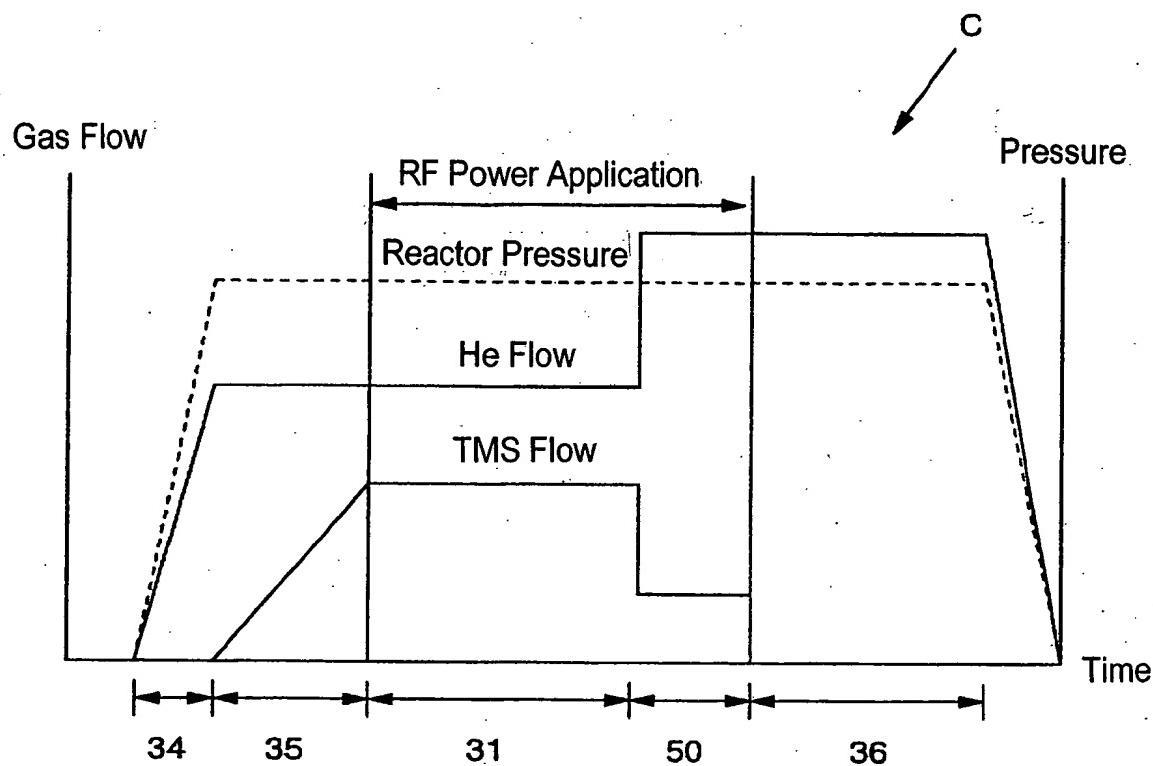


FIG. 4

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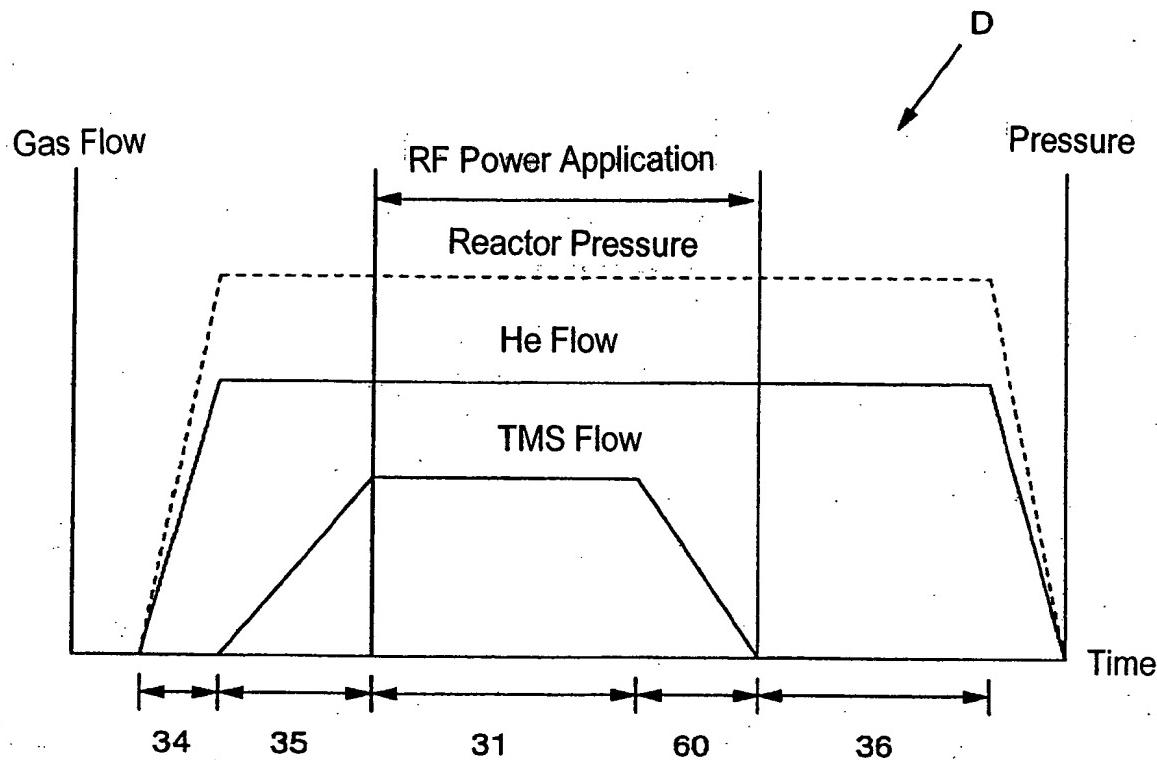


FIG. 5.

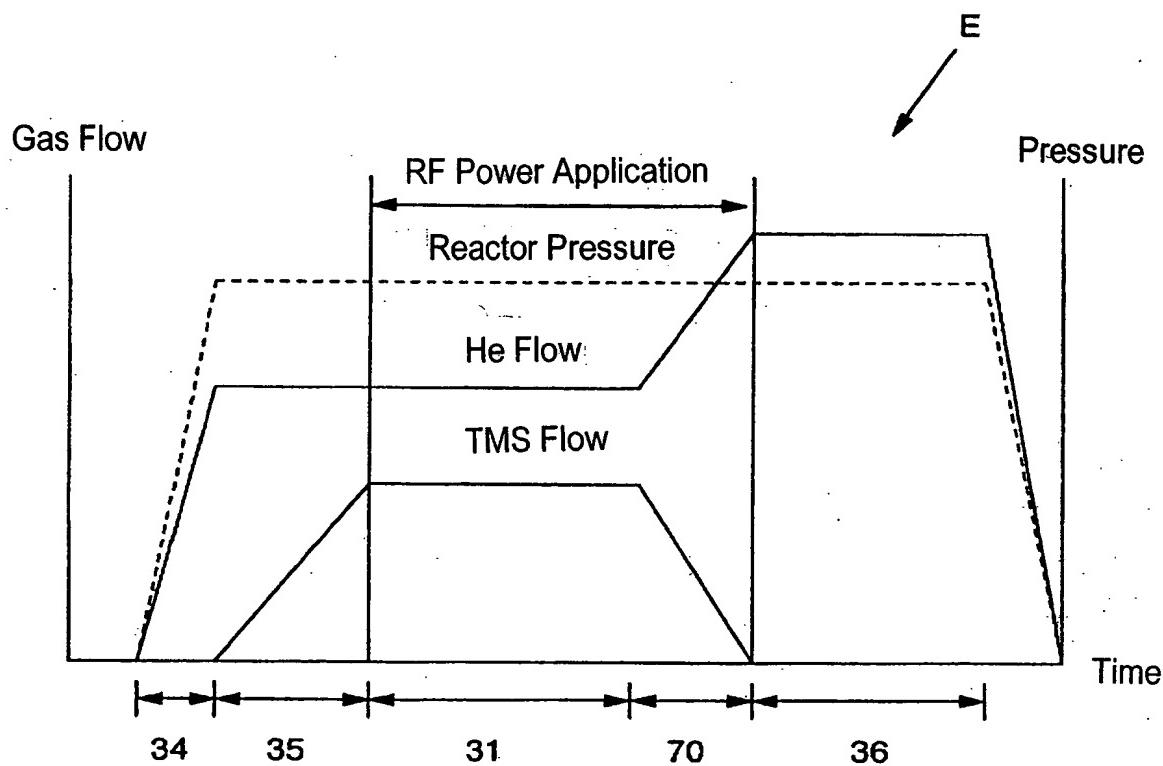


FIG. 6

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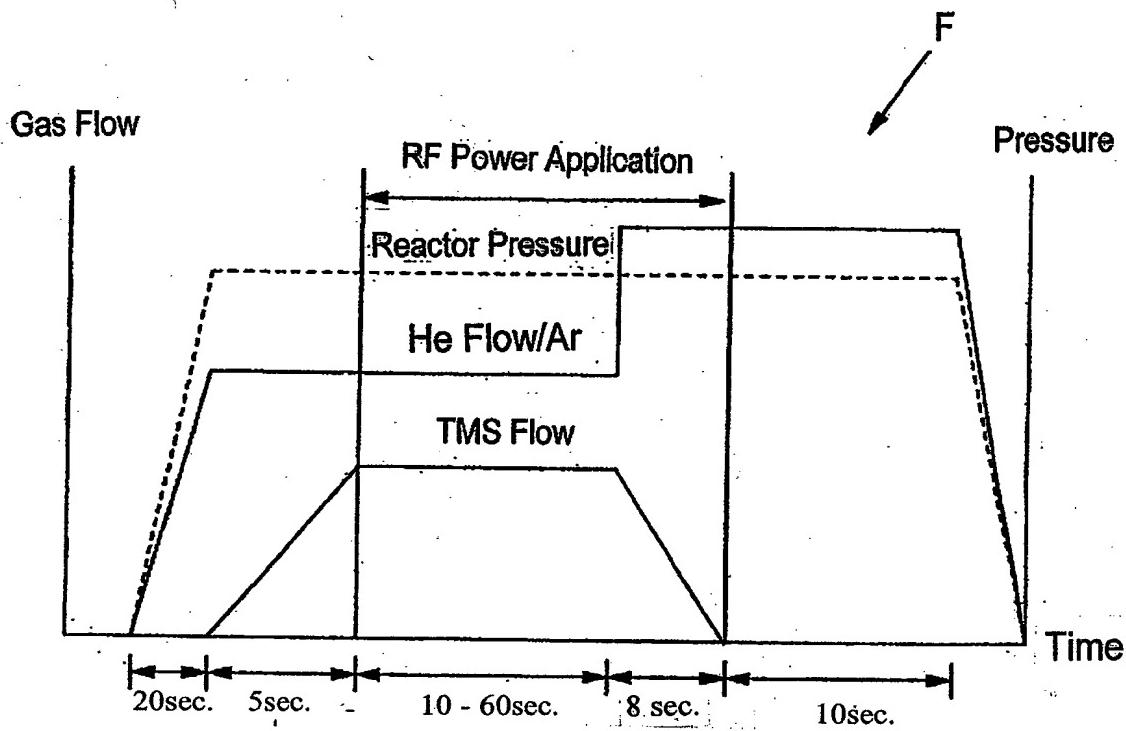


FIG. 7

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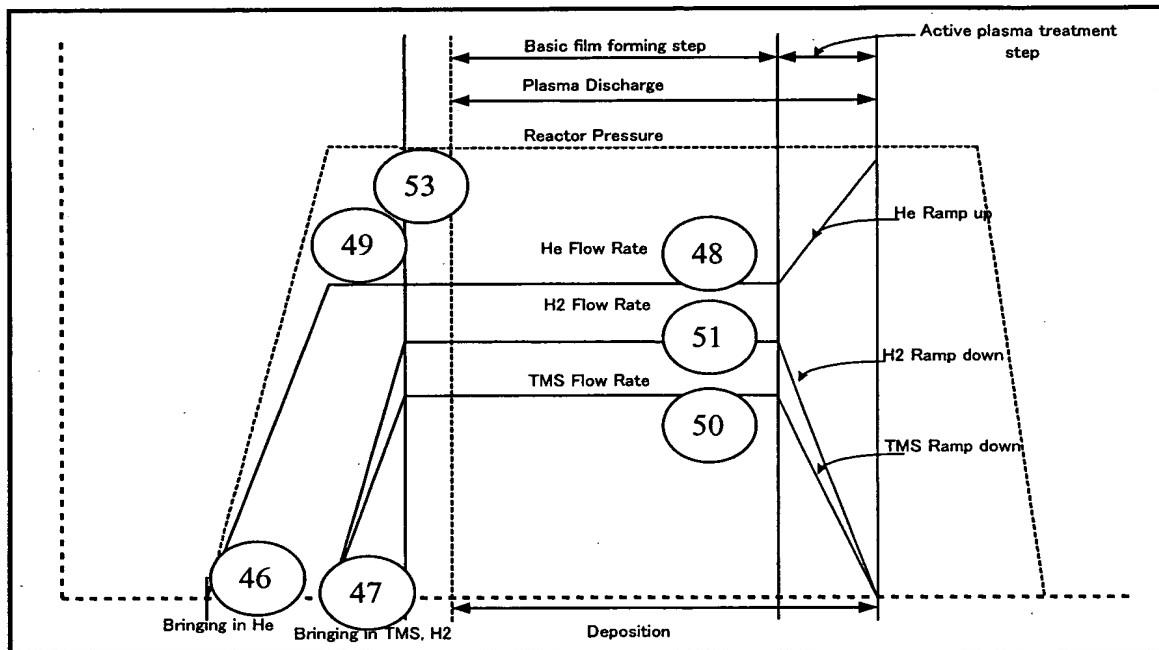


FIG. 8

FIG. 9a

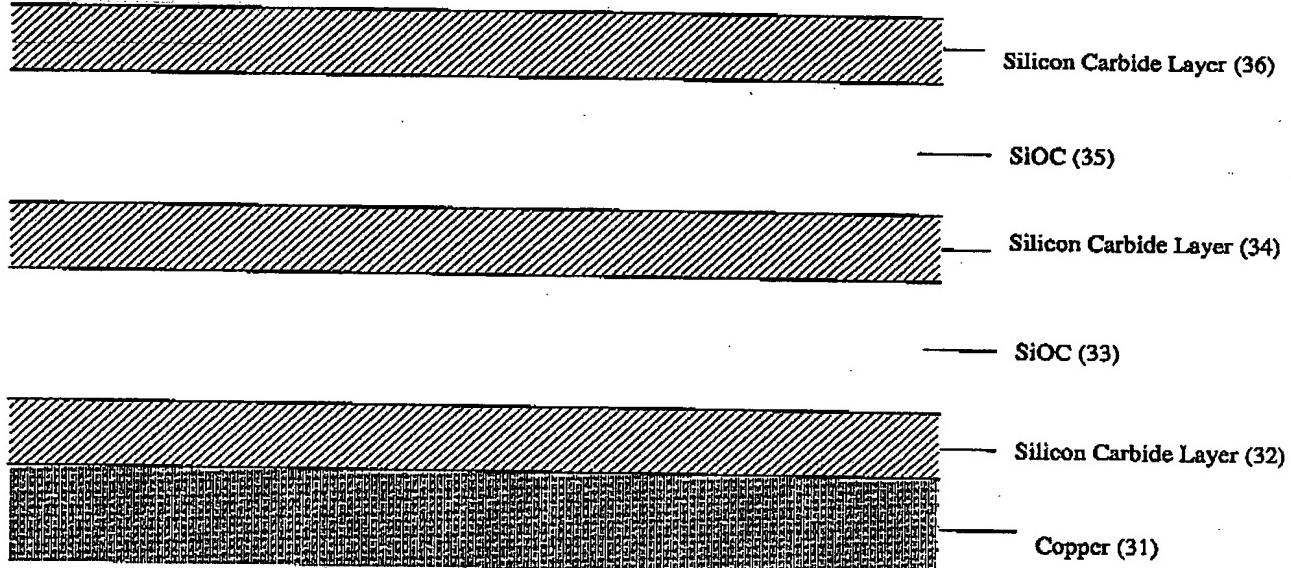


FIG. 9b

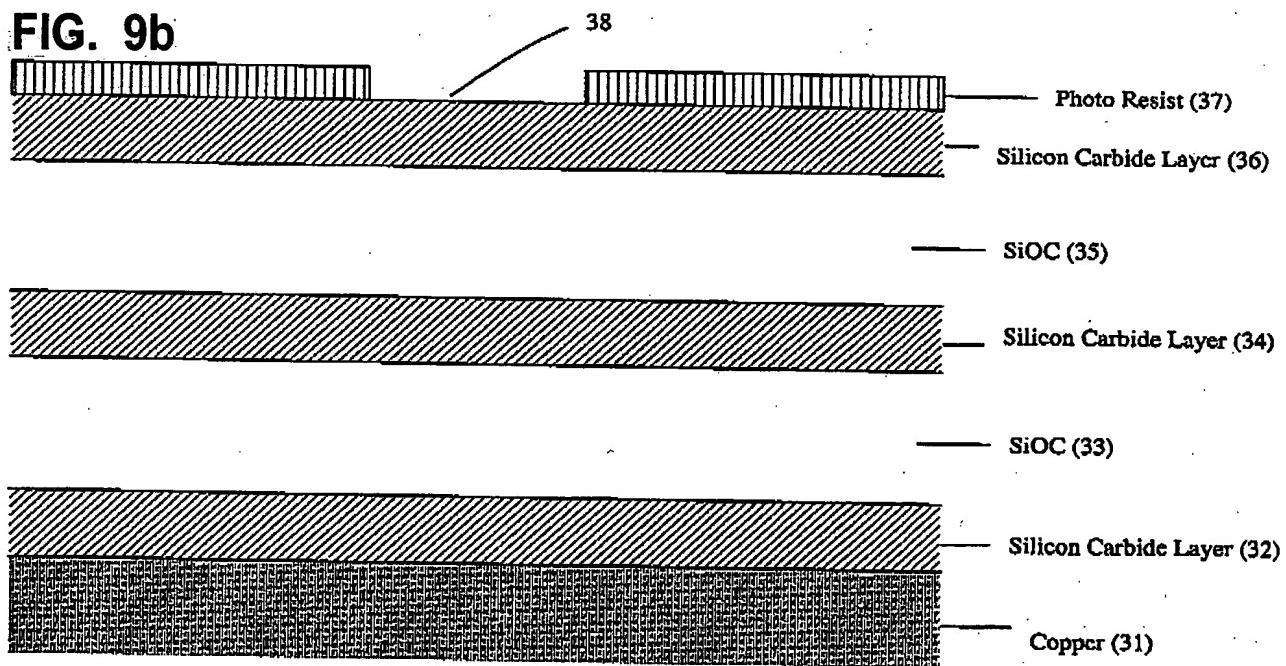


FIG. 9c

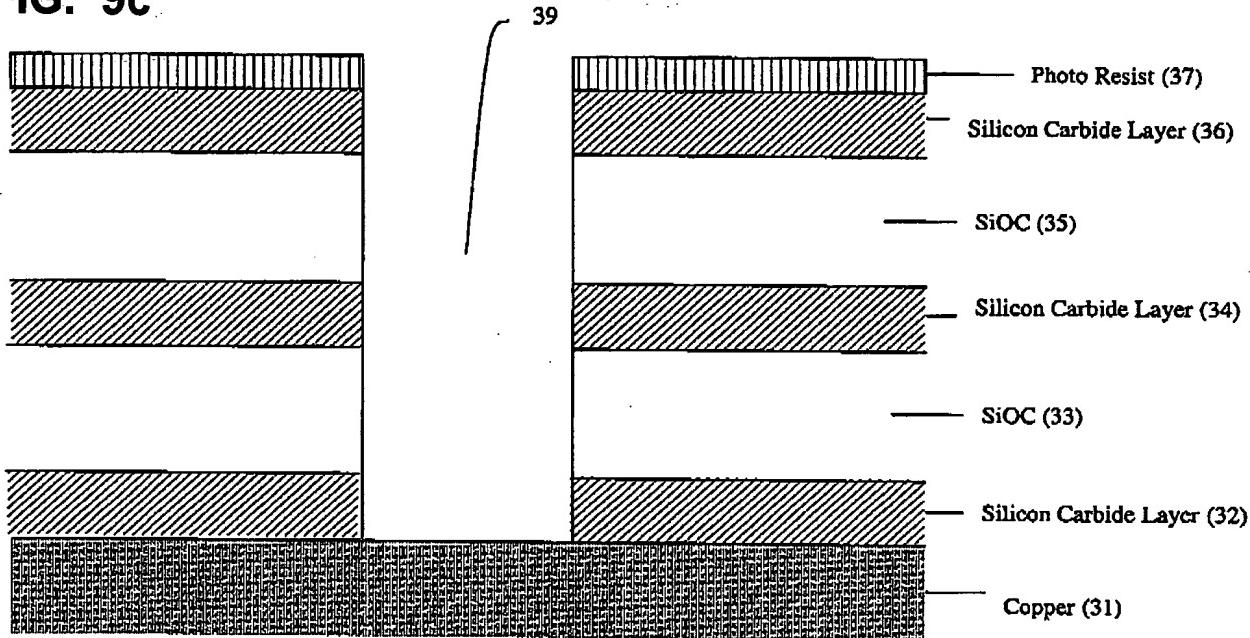
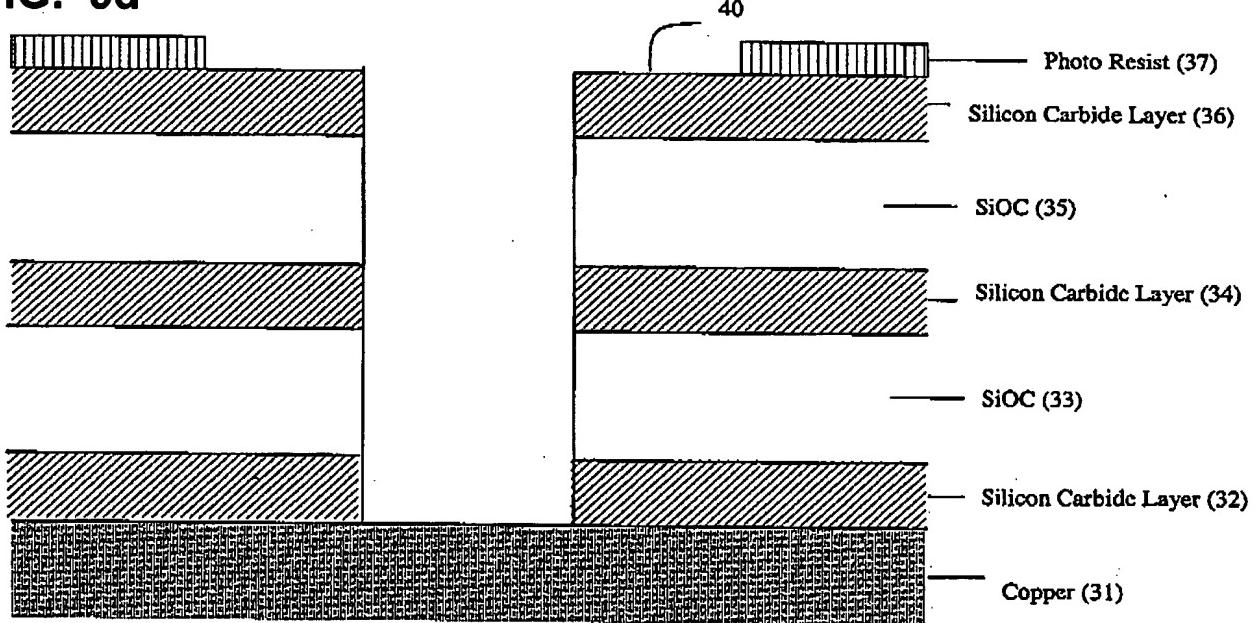


FIG. 9d



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FIG. 9e

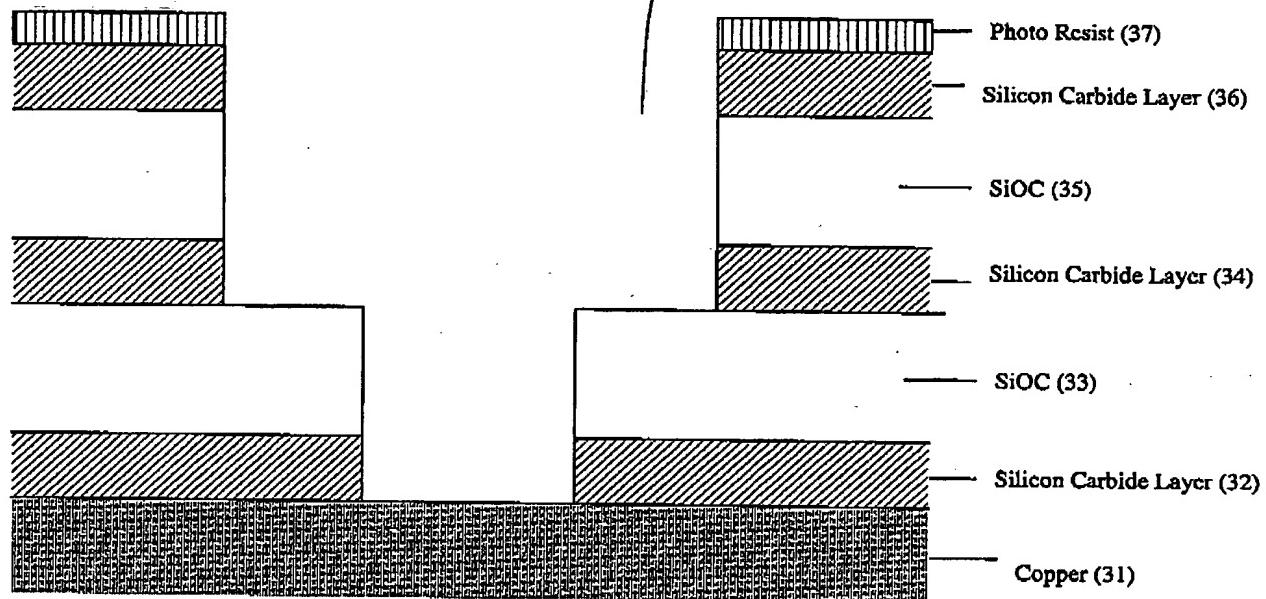
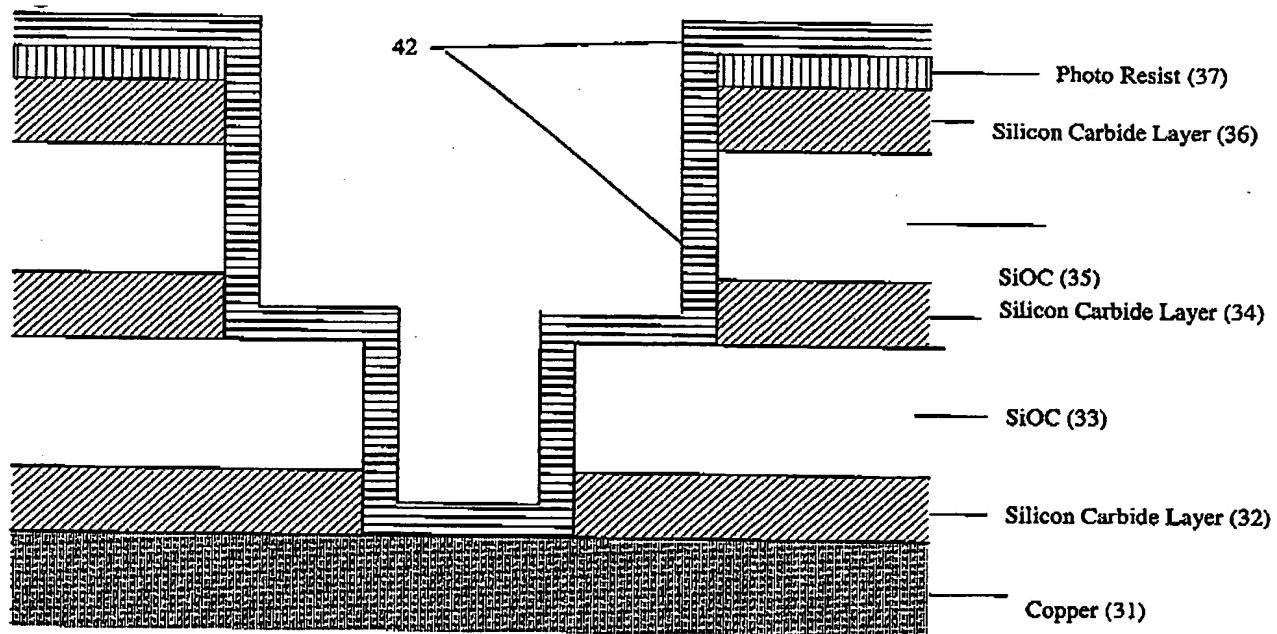


FIG. 9f



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FIG. 9g

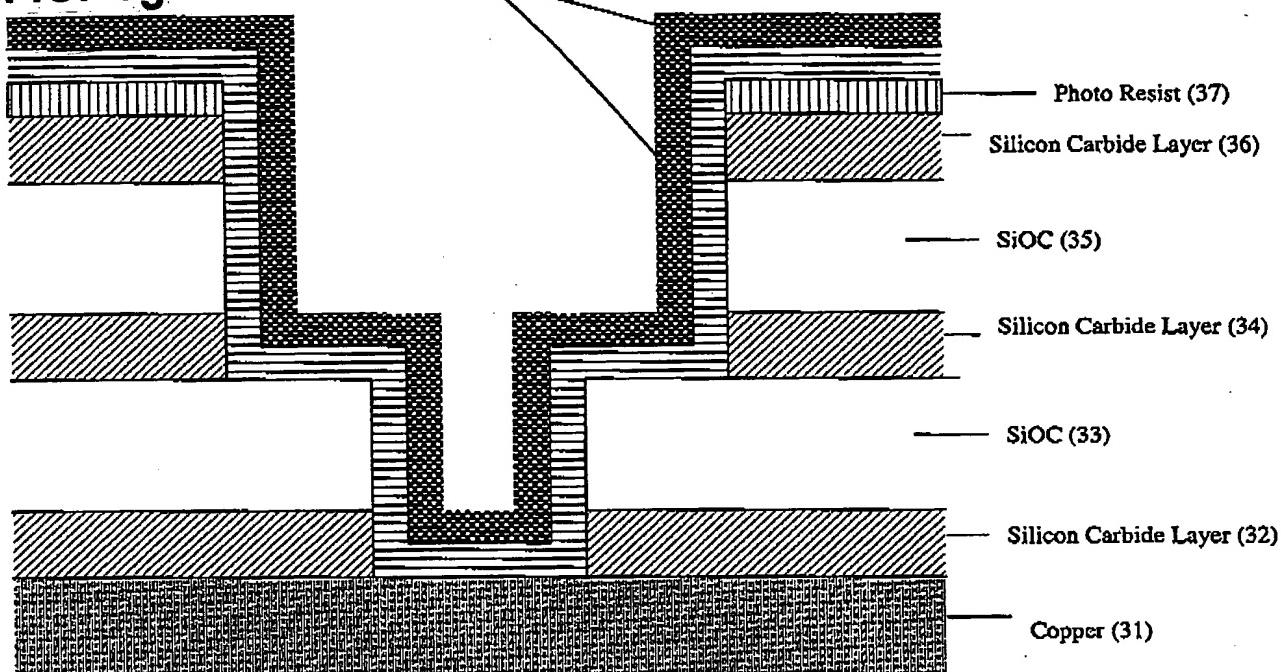


FIG. 9h

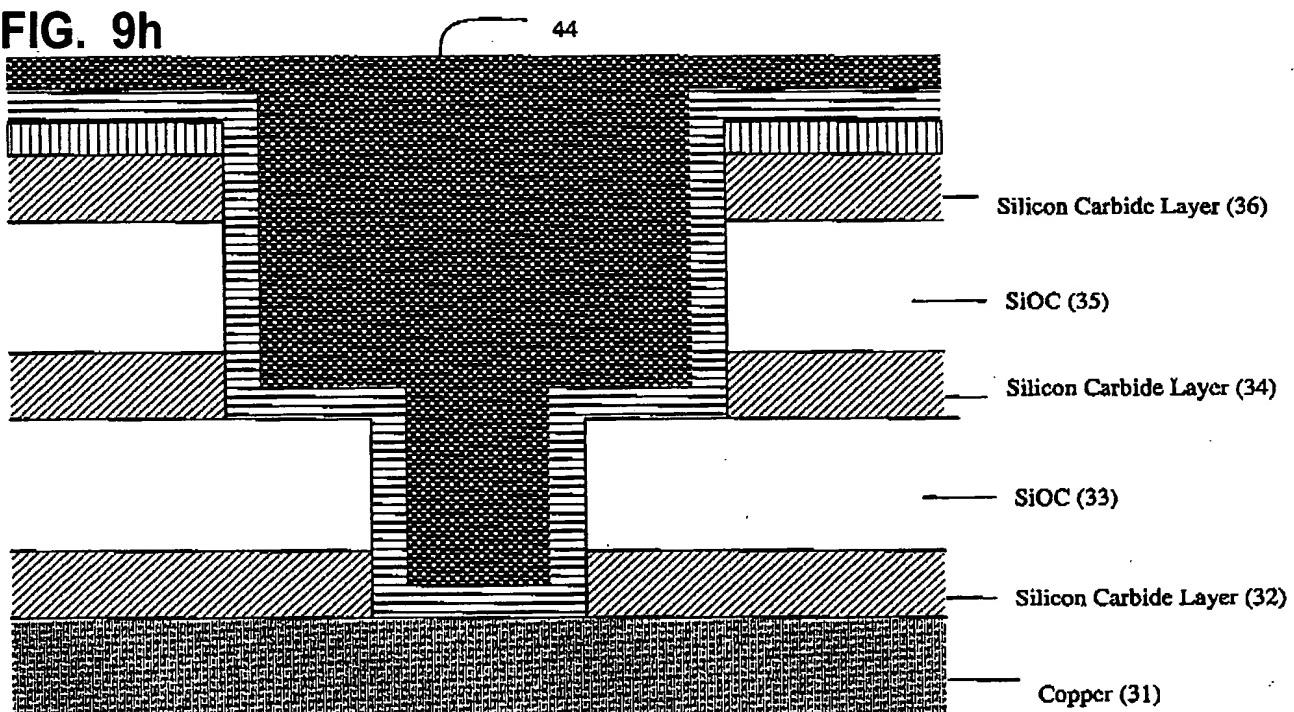


FIG. 9i

